PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q81050

Hiroshi ENDO, et al.

Appln. No.: 10/825,673

Group Art Unit: 2622

Confirmation No.: 8654

Examiner: Chia Wei A. Chen

Filed: April 16, 2004

For:

DIGITAL CAMERA

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on December 13, 2007:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was sent dated December 17, 2007.

During the interview, the rejections of claims 4, 5, and 12 was discussed. The Examiner clarified these rejections. It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to

STATEMENT OF SUBSTANCE OF INTERVIEW U.S. Application No. 10/825,673

maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,

Registration No. 55,470

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Date: March 24, 2008